## NOTES:

- 1. SUBSTRATE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL TO SURFACE S1 TO WITHIN <3 ARCMIN
- 3. COATING (APPLY ACROSS COATING APERTURE):

\$1: 532 HR Coating R (ABS) > 99.80% @ 532nm @ 0-45° AOI

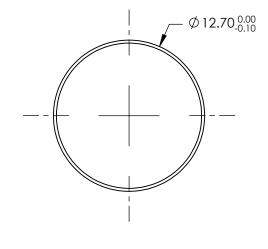
DAMAGE THRESHOLD, PULSED: 10 J/cm², 20ns, 20Hz @ 532nm CW: 1MW/cm² @ 532nm

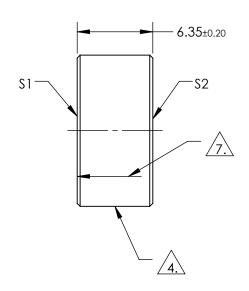
S2: NONE

4. FINE GRIND SURFACE

- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. CLEAR APERTURE AND COATING APERTURE ARE CENTERED ON SURFACES

APPLY ARROW ON EDGE WITH LASER ETCH, PENCIL, OR PERMANENT INK POINTING TOWARDS SURFACE ST





## FOR INFORMATION ONLY: DO NOT MANUFACTURE PARTS TO THIS DRAWING

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

SHAPE SURFACE QUALITY	PLANO 10-5	PLANO COMMERCIAL POLISH	-	R	<b>Edmund Optics</b>	<b>3</b> ®
SURFACE GUALITY SURFACE FLATNESS	0.10 WAVE	N/A				
MIN CLEAR APERTURE	Ø11.43	N/A	THIRD ANGLE PROJECTION	TITLE	Ø12.7mm x 6.35mm,532nm, NdYAG MIRR( 0-45° AOI	COR
MIN COATING APERTURE	Ø11.43	N/A				CLIEFT
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN mm	DWG NO		SHEET 1 OF 1